



**IN THE
UNITED STATES
PATENT AND TRADEMARK OFFICE**

IN RE APPLICATION OF: Kirchner et al.

CASE: OST-041134

SER. NO.: 10/815,116

FILING DATE: March 31, 2004

FOR: METHOD FOR DISTORTION CORRECTION
IN A MICROLITHOGRAPHIC PROJECTION
EXPOSURE APPARATUS

RESPONSE TO
FINAL OFFICE
ACTION MAILED
APRIL 24, 2007

COMMISSIONER
FOR PATENTS
Box RCE
P.O. Box 1450
Alexandria, VA 22313-1450

ATTENTION OF: Art Unit 2851

EXAMINER: Kevin C. Gutierrez

Dear Examiner:

Pursuant to 37 C.F.R. § 1.114, this Reply is a Request for Continued Examination in response to the Final Office Action mailed on April 24, 2007. Please consider the following remarks toward reconsideration and passage to allowance. Applicant respectfully requests a telephone interview with the Examiner prior to the next Office Action and will contact the Examiner shortly after the filing of this response.

The current status of the **Claims** is reflected in the listing that begins on page 2 of this paper.

Remarks/Arguments begin on page 7 of this paper.

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